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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **KANO et al.**

Group Art Unit: 2812

Serial No.: 09/941,982

Examiner: **Mulpuri, Savitri**

Filed: **August 30, 2001**

P.T.O. Confirmation No.: 7536

For: **METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR LAYER, AND  
METHOD OF MANUFACTURING NITRIDE-BASED SEMICONDUCTOR  
DEVICE**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: October 9, 2003

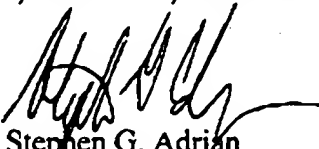
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Notice of Appeal filed July 8, 2003 for two months from September 8, 2003 to November 8, 2003.

Attached please find a check in the amount of \$420.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866. This paper is filed in triplicate.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
Stephen G. Adrian  
Attorney for Applicants  
Reg. No. 32,878

SGA/arf

Atty. Docket No. **011083**  
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**FAX RECEIVED**

**OCT 15 2003**

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